

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No. 10/071,425
 Filing Date February 8, 2002
 Inventorship Terry L. Gilton et al.
 Assignee Micron Technology, Inc.
 Group Art Unit 2813
 Examiner Thanhha S. Pham
 Attorney's Docket No. MI22-1828
 Customer No. 021567
 Title: Semiconductor Processing Method Using Photoresist and an Antireflective
 Coating


SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

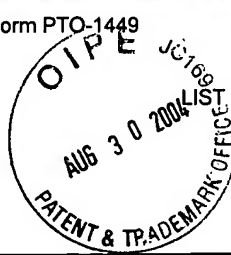
References - See Attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. Copies of the cited art references are attached. No admission is made regarding whether all the submitted references are prior art.

This Supplemental Information Disclosure Statement is being filed before the mailing of a first office action after the filing of a Request for Continued Examination. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. § 1.17(p) to Deposit Account No. 23-0925.

Respectfully submitted,

Dated: 8/30/04
 By: 
 Mark S. Matkin
 Reg. No. 32,268

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1828		SERIAL NO. 10/071,425	
 LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT: Terry L. Gilton et al.			
				FILING DATE February 8, 2002		GROUP 2813	
U.S. PATENT DOCUMENTS							
*Examiner's Initials	AA	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	4,368,099	01/11/83	Huggett et al.			
	AB	6,350,559 B1	02/26/02	Templeton et al.			
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes No
	AJ						
	AK						
	AL						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AM						
	AN						
	AO						
EXAMINER		DATE CONSIDERED					
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